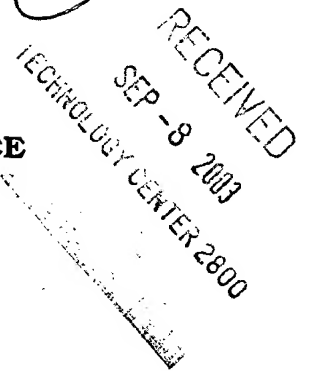




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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of
HORNING et al.

Serial Number:
09/873,931

Filed: June 4, 2001

For:
APPLICATIONS OF A
STRAIN-COMPENSATED
HEAVILY DOPED ETCH STOP
FOR SILICON STRUCTURE
FORMATION

Group Art Unit:
2814

Examiner:
Steven H. Rao

Docket No. H16-16009

To the Commissioner of Patents and Trademarks:

Sir:

AMENDMENT

Please enter the following amendments in response to the Office Action mailed April 23, 2003. Please extend the period for response from July 23, 2003, to August 23, 2003. Enclosed is check no. 5454 in the amount of \$110.00 for the one (1) month extension fee. Also enclosed are formal drawings.

IN THE CLAIMS

Cancel claims 1-18 as drawn to a nonelected group, without prejudice to filing a divisional application on these claims.

Amend the claims as follows:

08/27/2003 AHAB11 00000045 09873931 110.00 00
01 FC:1E51